



UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI et al.**

Art Unit: **1792**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR
STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.116
EXPEDITED PROCESSING REQUESTED

MAIL STOP AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September 30, 2008

Sir:

In response to the Office Action dated June 12, 2008, **for which the response date is extended by one month to October 12, 2008**, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

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